



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Luetzen, *et al.*

Docket No.: INF115

Serial No.: 10/721,225

Art Unit: 1763

Filed: November 26, 2003

Examiner: George A. Goudreau

For: Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed May 12, 2006. Please amend the above-referenced application as follows.